IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Isabelle Chartier et al.

SERIAL NO.: 10/560,405

FILING DATE: December 12, 2005 CONFIRMATION NO.: 5533

TITLE: Method Of Bonding Microstructured Substrates

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ART UNIT: 1791

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is responsive to the Office Action mailed **November 7, 2008**. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.